

**Application Data Sheet****Application Information**

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	VAPOR PHASE GROWTH METHOD FOR AI-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR PRODUCING AI-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR
Attorney Docket Number::	121213
Suggested Drawing Figure::	
Total Drawing Sheets::	5
Small Entity::	No

**Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Akinori
Family Name::	KOUKITSU
City of Residence::	Koganei-shi
Country of Residence::	JAPAN

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Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Yoshinao
Family Name::	KUMAGAI
City of Residence::	Koganei-shi
Country of Residence::	JAPAN

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Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Tomohiro
Family Name::	MARUI
City of Residence::	Koganei-shi
Country of Residence::	JAPAN

### Correspondence Information

Correspondence Customer Number:: 25944

<b>Domestic Priority Information</b>			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP03/04408	4/7/2003
<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2002-106102	4/9/2002	Yes
<b>Assignee Information</b>			
Assignee Name::		TOKYO UNIVERSITY AGRICULTURE AND TECHNOLOGY TLO CO., LTD	
Street of mailing address::		24-16 Naka-cho 2-chome,	
City of mailing address::		Koganei-shi,	
State or Province of mailing address::		Tokyo	
Country of mailing address::		JAPAN	
Postal or Zip Code of mailing address::		184-8588	